



Docket No.: 49657-961

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of

Kenji ITOGA, et al.

Serial No.: 09/769,490

Group Art Unit: 2882

Filed: January 26, 2001

Examiner: C. Kao

For: X-RAY EXPOSURE APPARATUS, X-RAY EXPOSURE METHOD, X-RAY MASK, X-RAY MIRROR, SYNCHROTRON RADIATION APPARATUS, SYNCHROTRON RADIATION METHOD AND SEMICONDUCTOR DEVICE

#20/86
MFB
12/29/03

PETITION FOR EXTENSION OF TIME

Mail Stop Extension of Time
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

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JUL 30 2003
TECHNOLOGY CENTER 2800

Sir:

It is respectfully requested that the time for response to the Office Action dated March 27, 2003, now due to expire June 27, 2003, be extended for one (1) month and set to expire on Sunday, July 27, 2003 (Monday July 28, 2003).

Please charge the extension fee of \$110.00 to Deposit Account No. 500417. Please charge any additional fees or credit any overpayment to Deposit Account No. 500417.

Respectfully submitted,

MCDERMOTT, WILL & EMERY

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Date: July 28, 2003

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